

WEST

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Search Results -

Term	Documents
(1 SAME 5).USPT,PGPB.	80

Database:

US Patents Full-Text Database
 US Pre-Grant Publication Full-Text Database
 JPO Abstracts Database
 EPO Abstracts Database
 Derwent World Patents Index
 IBM Technical Disclosure Bulletins

Refine Search:

11 same 15

Clear

Search History**Today's Date: 10/31/2001**

<u>DB Name</u>	<u>Query</u>	<u>Hit Count</u>	<u>Set Name</u>
USPT,PGPB	11 same 15	80	<u>L6</u>
USPT,PGPB	(hydrogen peroxide or "H.sub.2 O.sub.2" or "H2O2")	57154	<u>L5</u>
USPT,PGPB	13 and @pd<19970214	27	<u>L4</u>
USPT,PGPB	11 same (ozone or "O.sub.3")	52	<u>L3</u>
USPT,PGPB	11 and @pd<19970214	2264	<u>L2</u>
USPT,PGPB	((((remov\$3 or etch\$3 or contact\$3 or clean\$3 or eliminat\$3) same (polymer\$2 or resin or photoresist or resist or organic))same (substrate or wafer or semiconductor or electronic or circuit)) same ((acetic acid or "CH.sub.3 COOH" or ethanoic adj2 acid or vinegar acid or methane near carboxylic acid or acetate or carbonate or phosphonic acid)))	3395	<u>L1</u>

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Help

Logout

Interrupt

Main Menu

Search Form

Posting Counts

Show S Numbers

Edit S Numbers

Preferences

Search Results -

Term	Documents
@PD.USPT,PGPB.	6831961
(7 AND (@PD < "19970214")).USPT,PGPB.	27

Database:

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Refine Search:

17 and @pd<19970214

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Search History**Today's Date: 10/31/2001**

<u>DB Name</u>	<u>Query</u>	<u>Hit Count</u>	<u>Set Name</u>
USPT,PGPB	17 and @pd<19970214	27	<u>L8</u>
USPT,PGPB	14 same (ozone or "O.sub.3")	52	<u>L7</u>
USPT,PGPB	15 and @pd<19970214	85	<u>L6</u>
USPT,PGPB	14 and ((134/\$)!.CCLS.)	151	<u>L5</u>
USPT,PGPB	12 same l3	3395	<u>L4</u>
USPT,PGPB	(acetic acid or "CH.sub.3 COOH" or ethanoic adj2 acid or vinegar acid or methane near carboxylic acid or acetate or carbonate or phosphonic acid)	393082	<u>L3</u>
USPT,PGPB	11 same (substrate or wafer or semiconductor or electronic or circuit)	86301	<u>L2</u>
USPT,PGPB	(remov\$3 or etch\$3 or contact\$3 or clean\$3 or eliminat\$3) same (polymer\$2 or resin or photoresist or resist or organic)	399505	<u>L1</u>